



## **EECS 143 Microfabrication Technology**

College of Engineering  
Department of Electrical Engineering and Computer Sciences  
University of California, Berkeley

Below are your weekly quizzes. You should print out a copy of the quiz and complete it before your lab section. Bring in the completed quiz to lab the week it is due.

[Week 3--Active Area Definition](#)

[Week 4--Gate Oxidation](#)

Week 5--Poly deposition--Will be given in lab after Microlab tour

[Week 6--Gate Definition](#)

[Week 7--Source/drain](#)

[Week 8--Contact cut](#)

[Week 9--Metallization](#)

[Week 10--Metal Definition](#)

[Week 11--Characterization \(I\)](#)

Week 12 – MEMS Characterization

Last update 11/9/2001

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